

Accelerator Department
BROOKHAVEN NATIONAL LABORATORY
Associated Universities, Inc.
Upton, L.I., N.Y.

AGS DIVISION TECHNICAL NOTE

No. 9

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November 30, 1965

STATUS REPORT (3) CONCERNING HIGH GRADIENT COLUMN AND
50 MEV FAST EMITTANCE DEVICE

Ion Source

During the shutdown, a duoplasmatron with small expansion cup ($\emptyset = 4$ mm) has been installed in the present preinjector. After some minor technical difficulties, (e.g., cooling problems of magnet and housing of the palladium leak; we now use freon supplied from a cooling unit on the bottom of the pit via teflon tubes) this source supplies around 75 mA after the column and injected without loss into the linac. Focusing at the low energy end of the column is performed like the one used with the PIG source; the geometry of the extractor has been modified into a "Berkeley" shaped one (see Fig. 1). Though the source output current can be as high as 200 mA, (see Status Report 2) upper limit of the present column plus pre-focusing system seems to be around 100 mA. At the high energy end the gridded electrostatic lens has been removed to increase the beam brilliance. The emittance (area/ π) measured at 750 keV is 8.7 cm mrad (brilliance around 1.5×10^8). A mean value of the PIG source (measured over June-July) is $.7 \times 10^{8*}$. With 30% H_2^+ an acceleration efficiency was obtained of 60%.

An important feature of beam alignment has to be mentioned; the beam from the column was misaligned with respect to the center of the transport system; alignment of the whole column improved the linac output with 20% which was not possible by optimizing with the steering coils.

We try to keep the duoplasmatron running in the present machine. There is a spare unit in the test rig, as well as a spare cathode stored and outgassing in a small vacuum chamber.

* One exceptional figure 1.6×10^8 of the PIG source was measured on October 1, 1965.

The duoplasmatron with large cup ($\geq \frac{1}{2}$ -in.) for the short column is assembled and it can be installed in the second test rig, which is now equipped with a mercury diffusion pump. Measurements on this source will be made with the same basic equipment as used for the present operational source, so that brilliances can be compared.

Accelerating Column

Power, water supply, crane facility and shielding have been installed in the 905A Building; a smooth ceiling will be finished soon.

Assembling of the ceramic-aluminum inner pot of the column has started; mounting on its base, installation of vacuum equipment and leak checking can be expected during December.

A set (15) of divider resistances ("bananas") will be H.V. tested; production of another 15 bananas will start as soon as the first set is full-proof.

The spark gaps have been made. Gradients of a spark gap as a function of gap distances have been measured in air, in SF₆ and in some combinations with N₂. Some of the graphs are presented in Fig. 2. Fluctuations in the gradients can be as high as 15%; especially at short gap distances. From these results, we choose the gap distance for air .9-in. or 50 kV breakdown voltage (running column up to 600 kV or 40 kV across the sparking gap). The gap distances for SF₆ at 15 psia should be 5/16-in., corresponding with a breakdown voltage of around 70 kV (running column up to 750 kV or 50 kV per section).

All parts for the measuring dome will be delivered before December 15 so that we can assemble the stack.

H.V. Supply (R.D.I.)

The R.D.I. has been removed to the 905A Building and first tests have been started.

Several parts have been repaired (toroidal coil, measuring resistances, rectifiers, etc.); the number of rectifier stages has been increased from 14 up to 16 so that higher voltages could be obtained; also the controls have been adapted to the new situation; 700 kV has been reached for minutes; a rectifier caused failure; for several hours 500 kV has been

obtained; in general, failure starts in the rectifiers. R.D.I. suggests another tube with improved glass features because it believes that the trouble is caused by localized rf currents in the glass. Adequate cooling of the tubes is another possible improvement.

The group has started to assemble an adequate bushing from R.D.I. to load resistor, as well as from load resistor to dome, using the same unshielded cable.

Six-hundred kV should be available at the end of December. The inner part of the column (electrodes, rigging of inner electrodes, solenoid, photographic emittance device, Faraday cup and source) will be all available after January 15, so that after two months from now, the assembly can be checked at 500-600 kV without the skirts (available in February 1966).

50 MeV Emittance Device

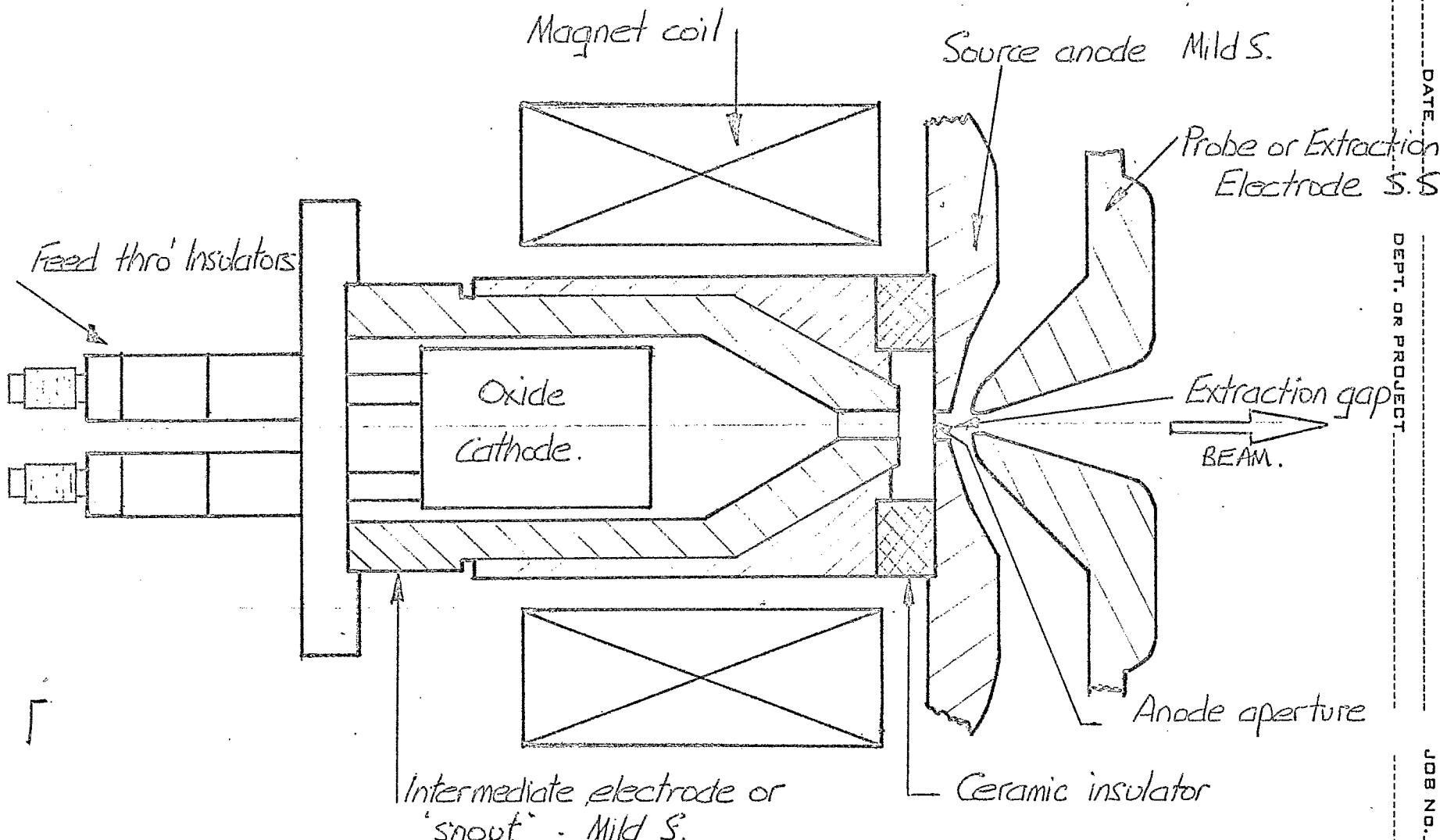
The emittance "box" can be assembled and equipped during the second part of December. Also, during this time, the controls can be installed.

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BY _____ DATE _____

CHKD. BY _____ DATE _____

SUBJECT _____

SHEET NO. _____ OF _____
JOB NO. _____

SCALE = FULL SIZE

Fig. 1

MAIN COMPONENTS OF OPERATIONAL DUOPLASMATRON. ION SOURCE

H. Wroe B.N.L. Sept 65

BROOKHAVEN NATIONAL LABORATORY

BY DATE SUBJECT

CHKD. BY DATE

DEPT. OR PROJECT

SHEET NO. OF

JOB NO.

-5-

L gft Spark gap test

10
8
6
4
2
1

air → atmosphere

here

corona discharge

Proposed gap dist.

10
8
6
4
2
1

10
8
6
4
2
1